

FORM PTO-1449 (Modified)		US DEPARTMENT OF COMMERCE		Docket No. 050623.245	Application No. 10/623,908			
US Patent and Trademark Office				Applicant Paul John Kawula				
INFORMATION DISCLOSURE CITATION in an Application (Use several sheets if necessary)				Filing Date July 21, 2003	Group Art Unit 3738			
U.S. PATENT DOCUMENTS								
Examiner Initial	Ref. No.	Document Number	Date of Patent	Name	Filing Date if Appropriate			
	A1							
U.S. PATENT APPLICATIONS								
Examiner Initial	Ref. No.	Document Number	Date of Patent	Name	Filing Date if Appropriate			
	A2							
FOREIGN PATENT DOCUMENTS								
Examiner Initial	Ref. No.	Document Number	Date of Publication	Country	Class	Subclass	Translation	
							Yes	No
/BP/	B1	WO 2005/113856	12/1/05	WIPO				X
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)								
/BP/	C1	Aluminium oxide, Wikipedia, the free encyclopedia, downloaded from http://en.wikipedia.org/wiki/Alumina , June 12, 2007, 5 pgs.						
/BP/	C2	Ceramic, Wikipedia, the free encyclopedia, downloaded from http://en.wikipedia.org/wiki/Ceramic , June 12, 2007, 8 pgs.						
/BP/	C3	"Ceramics-a.k.a. "burnt stuff"- contain at least 1 metal oxide", CCMR-Ask A Scientist, downloaded from http://www.ccmr.cornell.edu/education/ask/index.html?quid=1088 , June 12, 2007, 2 pgs.,						
/BP/	C4	Chen, "New Coating Process Enables Higher-Efficiency Engines", Berkeley Lab Research News, 1996, 3 pgs.						
/BP/	C5	Chen et al., "Al ₂ O ₃ - TiO ₂ composite oxide films on etched aluminum foil by gydrolysis precipitation and anodizing", J. Mater. Sci. 41, pp. 569-571 (2006).						
/BP/	C6	Ciridon et al., "Plasma Deposition", Biomaterials Tutorial, Univ. of Washington Engineered Biomaterials, 2004, 3 pgs.						
/BP/	C7	Holcombe Jr. et al., "Oxygen sensitive, refractory oxide composition", downloaded from http://www.patentdigi.com/liquid_crystal/oxygen_sensitive_refractory_oxide_composition , June 12, 2007, 7 pgs.						
/BP/	C8	Kern et al., "Electrolytic Deposition of Valve Metal Oxide Thin Films as Interference Coatings on Biomedical Implants", EU Cells and Materials vol. 10, Suppl. 1, 2005, pg. 25.						
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/BP/	C11	Wood et al., "Implantation and deposition of adherent metal-oxide ceramic", IEEE Xplore, downloaded from http://ieeexplore.ieee.org/xpl/freeabs_all.jsp?arnumber=533482 , June 12, 2007, 1 pg.						
EXAMINER /Brian Pellegrino/				DATE CONSIDERED 05/05/2008				
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